

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Tohru Koike et al.
Appl. No. : 10/575,714
Filed : May 8, 2006
For : METHOD FOR MEASURING A SURFACE PLASMON
RESONANCE AND NOBLE METAL COMPOUND USED FOR THE
SAME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

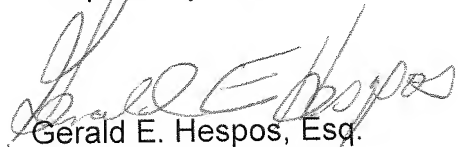
SECOND INFORMATION DISCLOSURE STATEMENT

Sir:

The above-identified U.S. patent application relates to Japanese Patent Appl. No. JP2006-077240. An Office Action was issued in connection with the Japanese application on October 6, 2009 and a copy of that Office Action is attached along with an English language translation. The Examiner will note that the Japanese Patent Office cited four non-patent publications and one Japanese reference. All of these references have been listed on the attached copy of Form PTO/SB/08A and copies of all the references are attached. The Japanese patent reference also is accompanied by an English language abstract obtained from the database of the Japanese Patent Office. Additionally, the Japanese language non-patent publication is accompanied by an English language translation.

The Examiner is requested to consider these references during the examination and to make the references of record.

Respectfully submitted,



Gerald E. Hespos, Esq.
Atty. Reg. No. 30,066
Customer No. 01218
CASELLA & HESPOS LLP
274 Madison Avenue - Suite 1703
New York, NY 10016
Tel. (212) 725-2450
Fax (212) 725-2452

Date: November 18, 2009